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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/783,419
Confirmation No. 6384
Filing Date February 19, 2004
Inventor..... Yoshiki Hishiro
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2814
Examiner G. Peralta
Attorney's Docket No. MI22-2507
Customer No. 021567
Title: Methods of Forming Semiconductor Constructions

PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
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AMENDMENTS